

**Notice of References Cited**

Application/Control No.

10/003,428

Applicant(s)/Patent Under  
Reexamination  
HATTORI ET AL.

Examiner

David Y. Chung

Art Unit

2871

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,400,437	06-2002	Nagata et al.	349/143
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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**FOREIGN PATENT DOCUMENTS**

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